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Form PTO-1449

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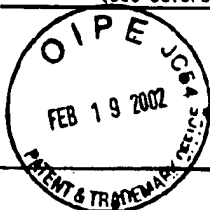
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STATEMENT BY APPLICANT

(Use several sheets if necessary)



APPLICANT
Cohen, et al.

FILING DATE February 11, 2000

GROUP

Art Unit 2814

U.S. PATENT DOCUMENT

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WSL	5 8 6 1 6 5 1	01/19/99	Brasen, et al.			
WSL	5 5 2 1 1 2 7	05/28/96	Hori			

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
2 3 3 4 8 1 8	01/09/99	United Kingdom			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Conference Record of the 1988 IEEE International Symposium on Electrical Insulation, Cambridge USA, 5-8 June 1988, Gerstenberg, On structure and properties of plasma polymerized organo-silicon films, pages 141-144.

EXAMINER

DATE CONSIDERED

4/9/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Form PTO-1449 [6-4])